

## UNITED STATES PATENT AND TRADEMARK OFFICE

## **COMMISSIONER OF PATENTS**

March 21, 2005

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Legal Affairs Dept.
P. O. Box 450A
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In re Application of: Jong Hyun Yoo et al Serial No: 10/023,125

On Petition

Filing Date: December 17, 2001

For: PULSE NUCLEATION ENHANCED NUCLEATION TECHNIQUE FOR IMPROVED STEP COVER AND BETTER GAP FILL FOR WCVD PROCESS

In response to the petitions received on July 29, 2004, to withdraw the holding of abandonment in the above application.

The petition is Granted.

The above-identified application became abandoned for failure to reply with the meaning of 37 C.D.R 1.113 in a timely manner to the Notice to File Missing Parts of Nonprovisional Application mailed February 21, 2002. Which set forth a shortened statutory period for reply of two months. Accordingly, the above-identified application became abandoned April 23, 2002. The notice of abandonment was mailed on June 25, 2004.

The evidence submitted is sufficient to establish that the petitioners responded to the Notice to File Missing Parts of Nonprovisional Application on August 18, 2002 with 5 months of extension of time.

The application was abandoned in error. The office regrets any inconvenience this may have caused the client.

Telephone inquiries concerning this application may be directed to Doshie E. Day (703) 308-3640.

Doshie E. Day

Program Management Assistant
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